



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Masaaki KURIHARA et al.

Serial No.: 10/614,345 Group Art Unit: Unassigned

Filed: July 8, 2003 Examiner: Unassigned

For: PHASE MASK FOR FORMING DIFFRACTION GRATING, METHOD  
OF FABRICATING PHASE MASK AND METHOD FOR FORMING  
DIFFRACTION GRATING

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-identified application,  
please enter the following changes: